Applicant(s)/Patent Under Reexamination Application/Control No. 10/528,140 MISAWA ET AL. Notice of References Cited Art Unit Examiner Page 1 of 1 2886 Andrew Hwa S. Lee **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,831,749	12-2004	Ohno et al.	356/483
	В	US-			
	C	US-			
	D	US-			
	Ε	US-			
	F	US-			
	G	US-			
	Н	US-			
	ı	US-			
	J	US-		·	
	к	US-			
	L	US-			.,,,
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	•				
	0					
	Р					
	Q					
	R					,
	s					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	v	·
	w	
	×	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.